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Atty Docket No. COHL-4340

In re Patent Application of: Yang Pang et al.

Application No.: 09/901,857

Filed: July 9, 2001

For: CLOSED-LOOP PURGING SYSTEM FOR LASER

Box NON-FEE AMENDMENT

Commissioner for Patents
Washington, D.C. 20231

Sir:

Transmittal herewith is an amendment in the above-identified application.

The fee has been calculated as shown below.

	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL	17	MINUS	20	0	x \$18 =	\$0
INDEP.	3	MINUS	3	0	x \$84 =	\$0
FIRST PRESENTATION OF MULTIPLE DEP CLAIMS					+ \$280	\$0
TOTAL						\$0

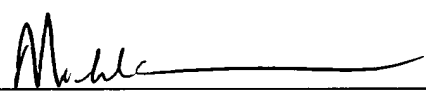
Small Entity 50% Filing Fee Reduction (if applicable) \$0

- * If the entry in Col. 1 is less than the entry in Col. 2, write "0" in Col. 3
** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 20, write "20" in this space.
*** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 3, write "3" in this space. The "Highest Number Previously Paid For" (Total or Independent is the highest number found from the equivalent box in Col. 1 of a prior amendment or the number of claims originally filed.)

- ☒ No additional fee is required.
- ☐ A check in the amount of \$_____ is attached.
- ☒ Please charge any additional fees, including any fees necessary for extensions of time or credit overpayment to Deposit Account No. 50-1703, under Order No. COHL-4340.
A duplicate copy of this sheet is enclosed.
- ☐ Petition for extension of time. The undersigned attorney of record hereby petitions for an extension of time pursuant to 37 C.F.R. § 1.136(a), as may be required, to file this response.

STALLMAN & POLLOCK LLP

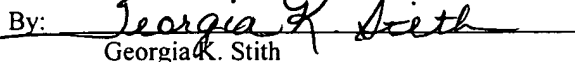
Dated: April 2, 2002

By: 
Michael A. Stallman (Reg. No. 29,444)
Attorneys for Applicant(s)

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on April 3, 2002.

Dated: April 3, 2002

By: 
Georgia K. Stith

#7/Re-Amend A
5-1-02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Yang Pang et al.

Application No.: 09/901,857

Filed: July 9, 2001

For: CLOSED-LOOP PURGING SYSTEM
FOR LASER

Group Art Unit: 2881

Examiner: Unknown

PRELIMINARY AMENDMENT121 Spear Street, Suite 290
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Commissioner for Patents
Washington, D.C. 20231**CERTIFICATE OF MAILING**I hereby certify that this correspondence is being deposited
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Washington, DC 20231 on April 3, 2002.

STALLMAN & POLLOCK LLP

Dated: 04/3/2002

By:

Georgia K. Stith

Sir:

Prior to examining the above-identified application, please amend the claims as follows:

IN THE CLAIMS

Please amend claim 1 as shown below:

1. (Amended) A method of minimizing contamination of optical components of a laser, the components being located in an gaseous atmosphere within enclosure, the gaseous atmosphere capable of containing contaminants including water vapor, organic vapor, and suspended particulate matter, the method comprising the steps of:

- (i) extracting gas from the atmosphere within the enclosure;
- (ii) passing the extracted gas through a first medium selected to reduce the water vapor content thereof;
- (iii) following step (ii), passing the extracted gas through a second medium selected to reduce the organic vapor content thereof;
- (iv) following step (iii) passing the extracted gas through a filter selected to reduce the particulate matter content thereof;

A/Conc

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